



Docket No.: 0941-0751P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Hung-Wen LEE et al.

Application No.: 10/600,539

Confirmation No.: 005767

Filed: June 23, 2003

Art Unit: 3714

For: WAFER SHIPPING DEVICE AND STORAGE  
METHOD FOR PREVENTING  
FLUORIDATION IN BONDING PADS

Examiner: J. A. Ricci

**AMENDMENT AND REPLY TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Restriction Requirement dated April 5, 2005, the following amendments, election, and remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Amendments to the Specification;

Amendments to the Claims; and

Remarks.

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